

<b>Notice of References Cited</b>		Application/Control No. 10/569,580	Applicant(s)/Patent Under Reexamination GOTO ET AL.	
		Examiner CHIA-WEI A. CHEN	Art Unit 2622	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2001/0004269	06-2001	Shibata et al.	348/333.06
*	B	US-2004/0201595	10-2004	Manchester, Scott	345/649
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
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	K	US-			
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#### FOREIGN PATENT DOCUMENTS

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	N					
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#### NON-PATENT DOCUMENTS

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